I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Mail Stop Patent Application
Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Attorney Docket No.: A4356/T035310
AMAT No.: 4356 USA

AMAT No.: 4356 USA D01/DSM/HDP/CVD/JW TTC No.: 016301-035310US

on September 8, 2003

TOWNSEND and TOWNSEND and CREW LLP

Nina L. McNeill

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Tetsuya Ishikawa et al.

Application No.: Not yet assigned

Filed: Not yet assigned

For: METHOD OF REDUCING PLASMA CHARGE DAMAGE FOR

PLASMA PROCESSES

Examiner: Not yet assigned

Art Unit: Not yet assigned

INFORMATION DISCLOSURE

STATEMENT UNDER 37 CFR §1.97 and

§1.98

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. This application is a divisional application and claims priority to U.S. Appl. No. 09/771,203 filed January 26, 2001 (the "parent application"). All of the references were submitted to or cited by the U.S. Patent and Trademark Office in the parent application. Therefore, copies of the references are not enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

Tetsuya Ishikawa et al.

Application No.: Not yet assigned

Page 2

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that <u>no fee is required</u> for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,

Patrick M. Boucher Reg. No. 44,037

Patul tre

TOWNSEND and TOWNSEND and CREW LLP

Tel: 303-571-4000 Fax: 415-576-0300

PMB:nlm 60031345 v1

Substitute for form 1449A/PTO	C mplete if Kn wn		
	Application Number		
INFORMATION DISCLOSURE	Filing Date		
STATEMENT BY APPLICANT	First Named Inventor	Ishikawa, Tetsuya	
	Art Unit	Not yet assigned	
(use as many sheets as necessary)	Examiner Name	Not yet assigned	
Sheet 1 of	Attorney Docket Number	A4356/T35310	

U.S. PATENT DOCUMENTS+								
Examiner Initials*	Cite No.1	Document Number Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
	AA	US-5,451,435	9/19/1995	Yu				
	AB	US-5,522,934	6/7/1996	Suzuki et al.				
	AC	US-5,614,055	03/1997	Fairbairn et al.				
	AD	US2001/00313 21 A1	10/18/2001	Ishikawa				
	AE	US-						
	AF	US-						
	AG	US-						
	AH	US-						
	Al	US-						
	AJ	US-						
	AK	US-						
	AL	US-						
	AM	US-						
	AN	US-						
	AO	US-						
	AP	US-						
	AQ	US-						
	AR	US-						
	AS	US-						
	AT	US-						

	FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ Number ⁴ Kind Code ⁵ (if known)		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶		
	AU	PCT	WO 99/57747	11/11/1999	Applied Materials, Inc.				
	AV	PCT	WO 01/03159 A1	01/2001	Dhindsa et al.				
	AW								
	AX								
	AY								
	AZ								
	BA								
	BB								

Examiner Signature	Date Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional).

Kind Codes of U.S. Patent Documents at www.uspto.gov or MPEP 901.04.

Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3).

For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible.

Applicant is to place a check mark here if English language Translation is attached.

60031345 v1

1	Substitute for form 1449B/PTO					Complete if Known		
			ON 5			Application Number		
					CLOSURE	Filing Date		
	STATEMENT BY APPLICANT				PPLICANT	First Named Inventor	Ishikawa, Tetsuya	
						Art Unit	Not yet assigned	
	(u	ise as man	ny sheet	s as	necessary)	Examiner Name	Not yet assigned	
	Sheet	2		of		Attorney Docket Number	A4356/T35310	

NON PATENT LITERATURE DOCUMENTS						
Examiner Cite (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.						
	вс	GYEONG S. HWANG et al., "Modeling of charging damage during interlevel oxide deposition in high-density plasma," Journal of Applied Physics, Vol. 84, Number 1, July 1998, pp. 154-160.				
	BD					
	BE					
	BF					

Examiner	Date	
Signature	Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached.